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033082 M 275

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Kazuhide Hasebe, et al.  
Serial No.: 10/552,262 Art Unit: Not Yet Assigned  
Filed: October 5, 2005 Examiner: Not Yet Assigned  
For: SILICON DIOXIDE FILM REMOVING METHOD AND  
PROCESSING SYSTEM

FOURTH INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

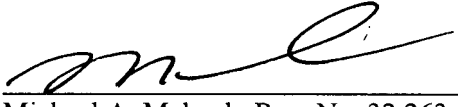
Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the references cited in the attached Japanese Office Action dated July 17, 2007.

Each item of information contained in this Information Disclosure Statement (PTO-1449) was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,  
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FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 033082 M 275	SERIAL NO. 10/552,262
	APPLICANT: Kazuhide Hasebe, et al.	
	FILING DATE October 5, 2005	GROUP ART UNIT 1765

### U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

### FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO	
	AL	03-147322	6/24/91	Japan			Abstract	
	AM	06-224153	8/12/94	Japan			Abstract	
	AN							
	AO							
	AP							

### OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	
	AR	
	AS	
EXAMINER:		DATE CONSIDERED:
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		